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HORST M KASPER

PAGE 01/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Karola Richter et al.
 Serial No: 10/553,728 Art Unit: 1765
 Filing Date: October 14, 2005
 Title: SILICON SUBSTRATE COMPRISING POSITIVE ETCHING
 PROFILES WITH A DEFINED SLOPE ANGLE AND PRODUCTION
 METHOD
 Examiner: Patricia Ann George

April 2, 2008 Attorney's Docket No.: HMP201T1

TRANSMITTAL LETTER

FAX NO. 571 273 1462

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